



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hao, *et al.* Docket No.: TSM03-0521
Serial No.: 10/631,251 Art Unit: 2812
Filed: July 31, 2003 Examiner: Luk, Olivia T.
For: Method for Fabricating Poly Patterns

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Examiner:

Applicants respectfully request reconsideration of the claims in view of the following amendments and remarks, which are submitted as a full and complete response to the Examiner's Office Action dated December 22, 2004.